

# Growth of (In,Ga)-(As,P) Nanowires by MOCVD

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## Outline

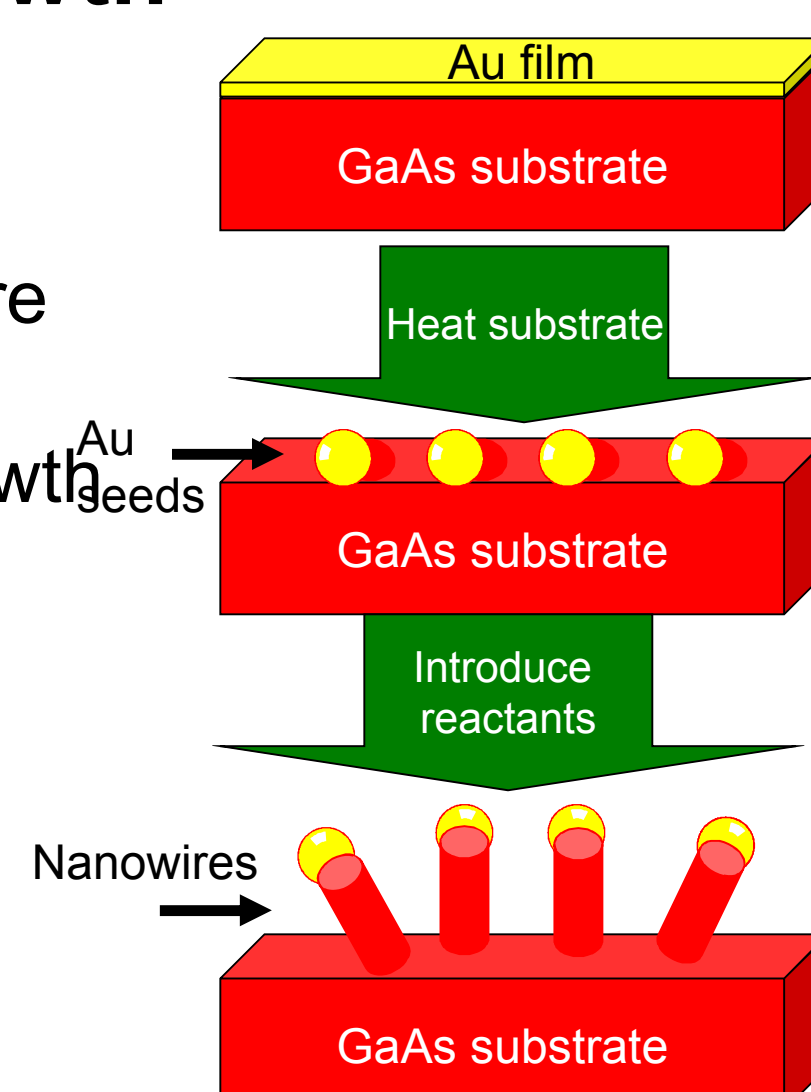
- Motivation
- Process details
- Initial growth demonstration of (In,Ga)-(As,P) nanowires
- Morphology sensitivity of GaAs nanowires
  - Effects of growth temperature and  $\text{AsH}_3$  partial pressure
- Nanowire growth model
- Oriented growth of GaAs nanowires
- Controlled size and placement of GaAs nanowires
- Doping issues for (In,Ga)(As,P) nanowires
- Conclusions

## Motivation

- Properties of materials modified by reducing dimensions (2D to 1D to 0D)
  - e.g. quantum wells, carbon nanotubes, quantum dots
- New physics and applications may be enabled by nanostructures
  - Photonics
  - Electronics
  - Sensors
- Reduced dimensions could allow integration of dissimilar materials
  - Eliminate defects due to lattice mismatch

## Nanowire Growth

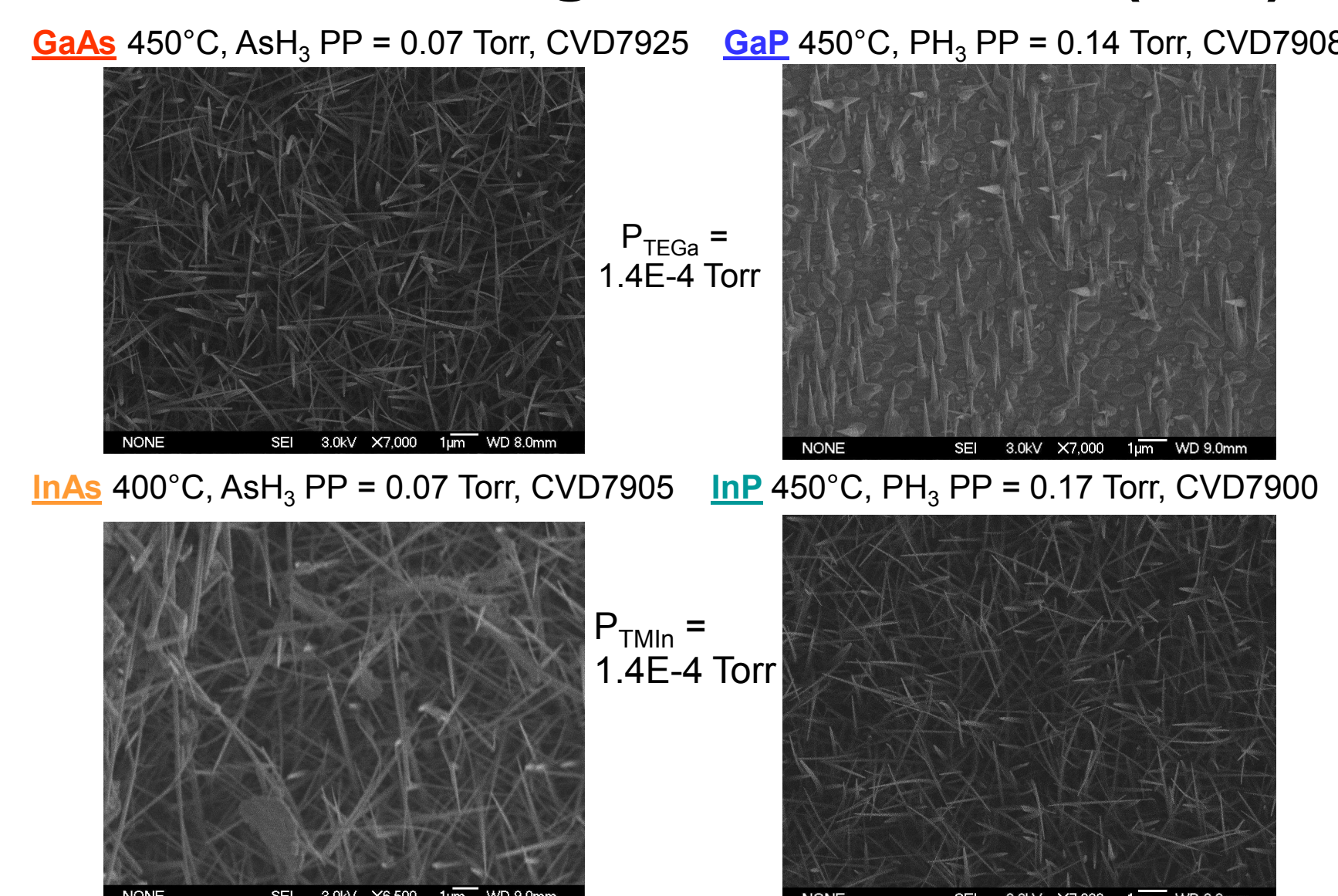
- Use Vapor Liquid Solid (VLS)/Vapor Solid Solid (VSS) technique
  - Use Au as “catalyst” for nanowire growth
  - Dispersed by anneal above growth temperature
- Use metal-organic chemical vapor deposition (MOCVD) to introduce reactants
- Nanowires can propagate normal to many crystal planes



## Initial Growth Conditions

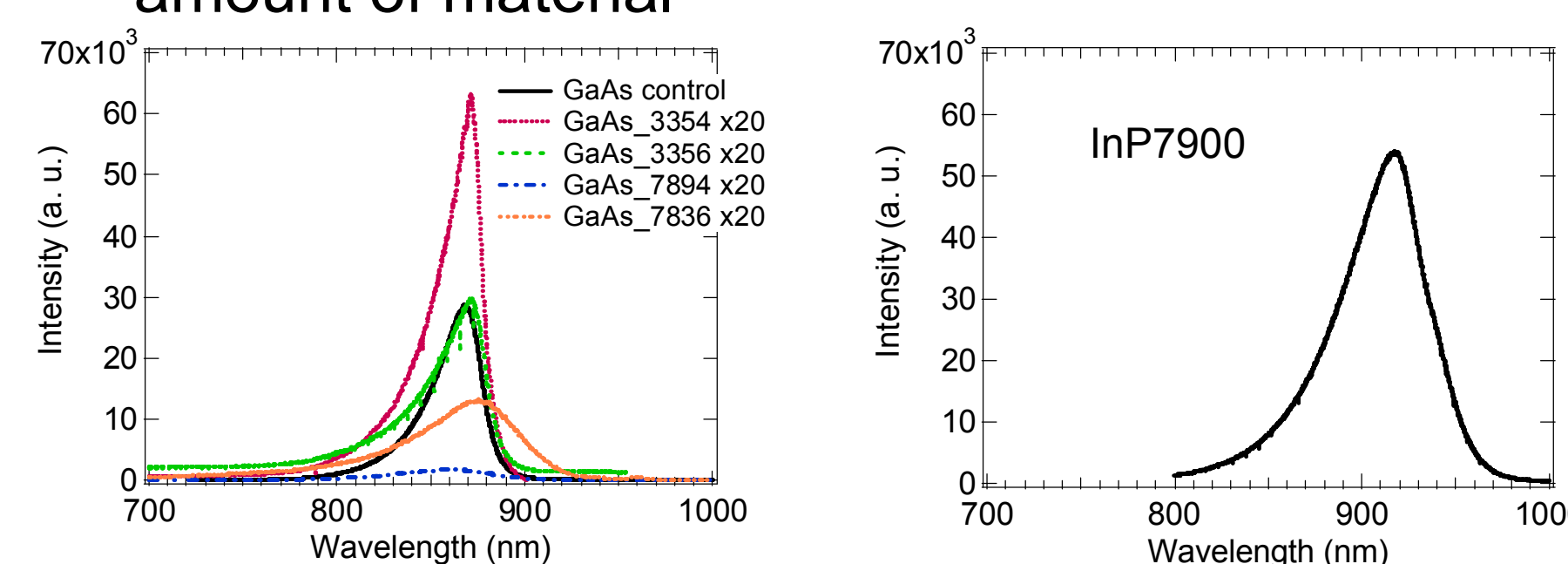
- Growth performed in vertical rotating disk growth chamber held at 70 Torr using  $\text{H}_2$  ambient.
- Use GaAs substrates covered with  $1 \pm 0.5$  nm of Au
- Au dispersed by heating sample under  $\text{AsH}_3$  to  $650^\circ\text{C}$  for 10 min
- Cooled to nanowire growth temperature
- Introduced appropriate gases
  - triethylgallium, trimethylindium, arsine, or phosphine
- All samples grown for 50 min

## Nanowires growth on GaAs(100)

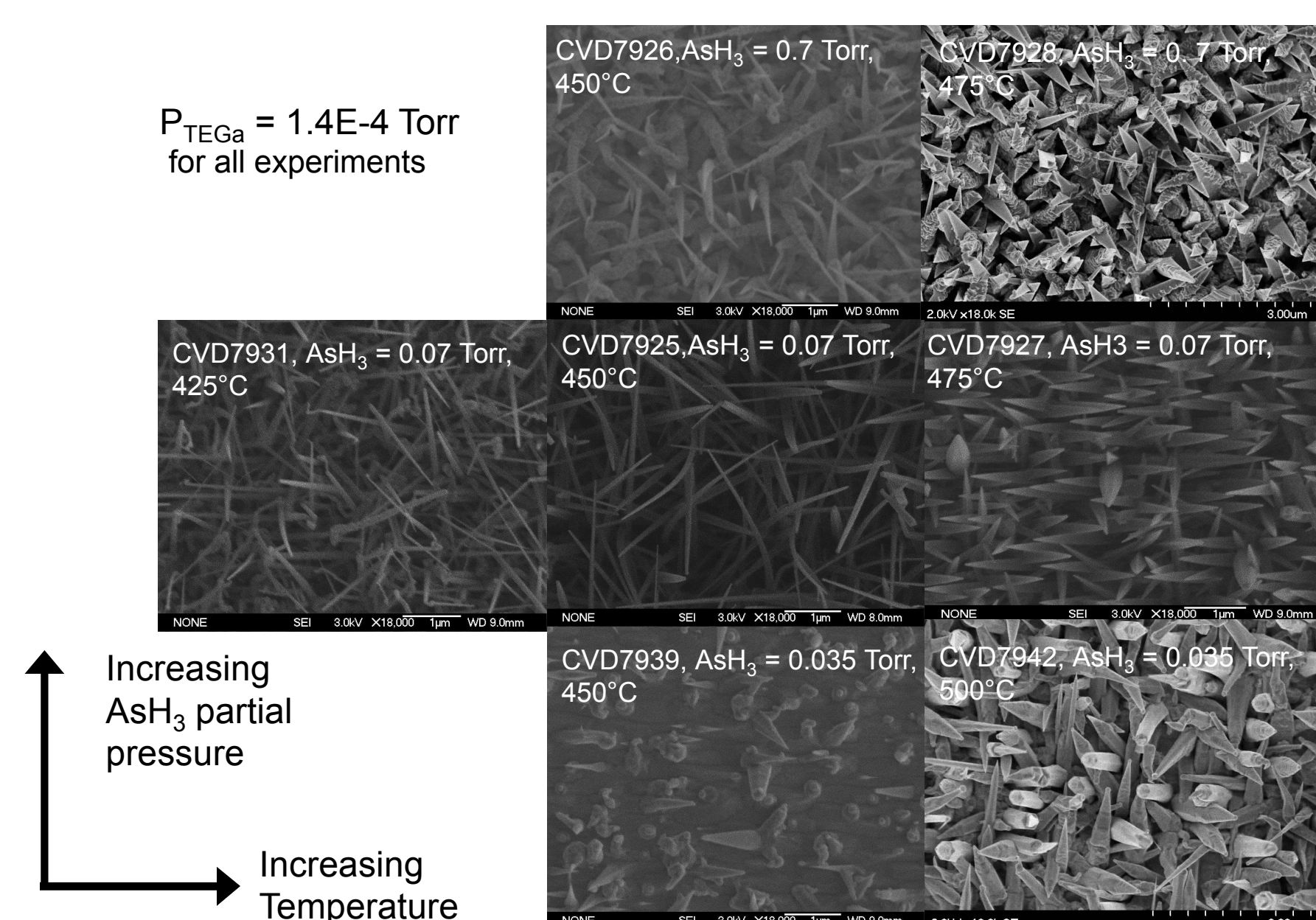


## Photoluminescence from GaAs and InP nanowires

- Observed room temperature PL from InP and GaAs nanowires
  - Resonances correspond to bandgap energies for bulk films
    - Suggests are nanowires are too large to observe quantum effects
  - FWHM for resonance is broader than for bulk films
    - InP nanowires have 88 meV FWHM, undoped planar InP has 39 meV FWHM
- Small signal from nanowires expected given small amount of material

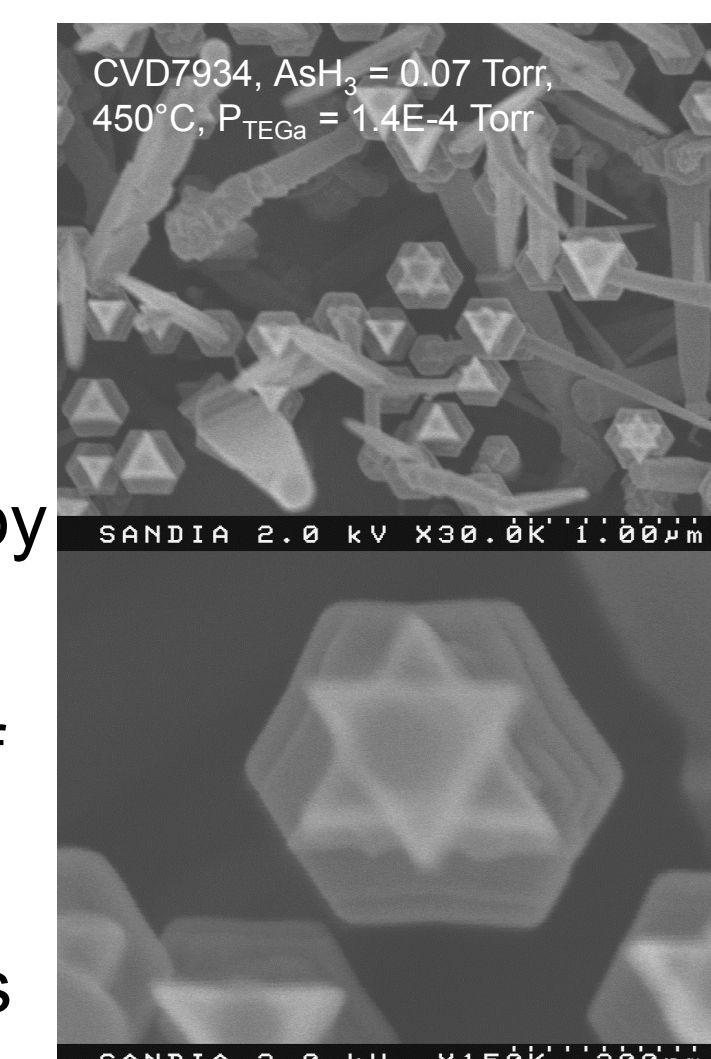


## Process Sensitivity for GaAs Nanowires

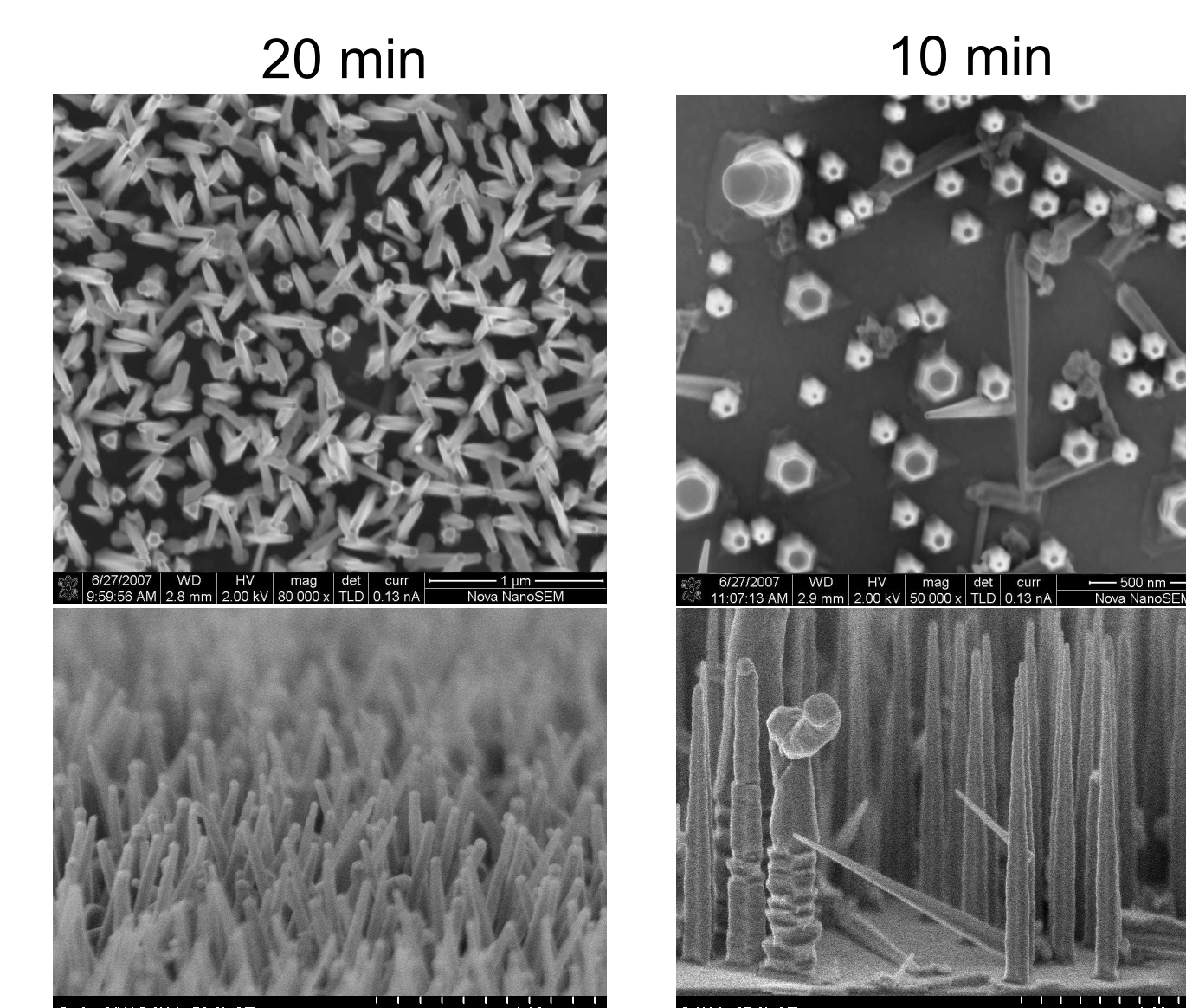


## Oriented Growth of GaAs Nanowires on (111)As substrates

- Performed growth on (111)As utilizing coalesced Au films following previous recipe
- Nanowires start growth normal to (111)As surface
  - Shows that growth proceeds by  $60^\circ$  rotation of crystal planes
  - Suggests that nanowires are wurzite (hexagonal) instead of zinc blende (cubic)
  - Form kinks that allow propagation in other directions

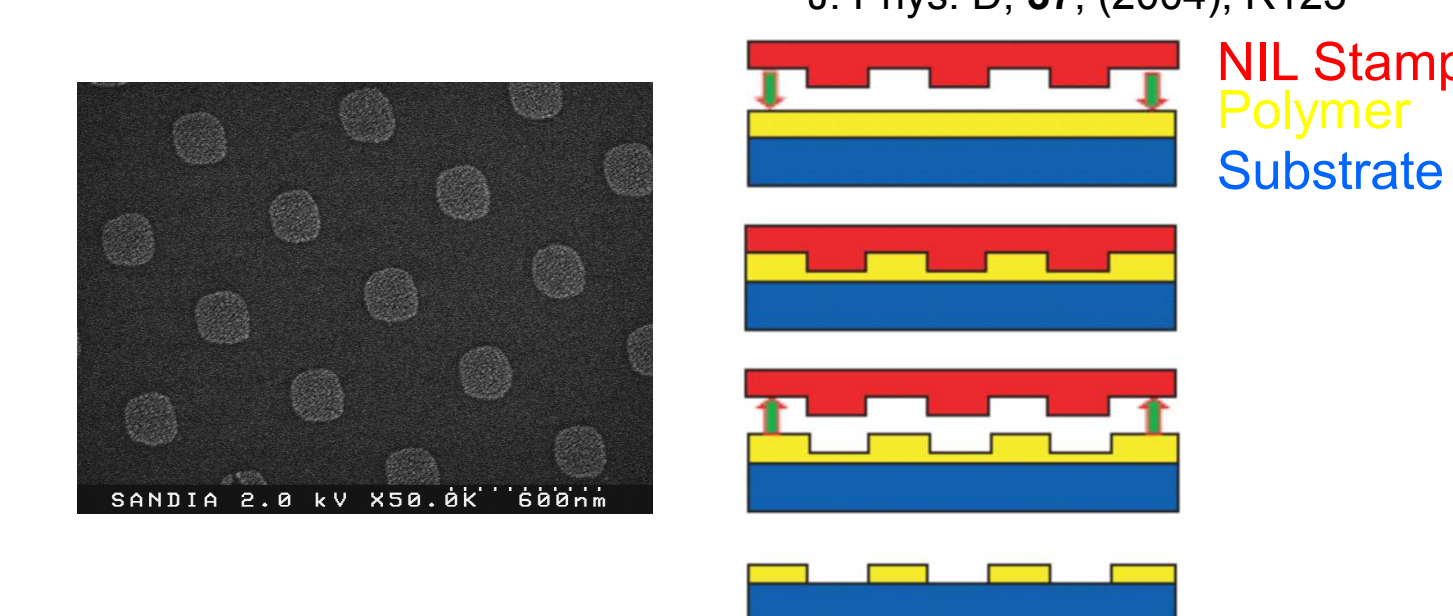


## Nanowire kinking determined by length

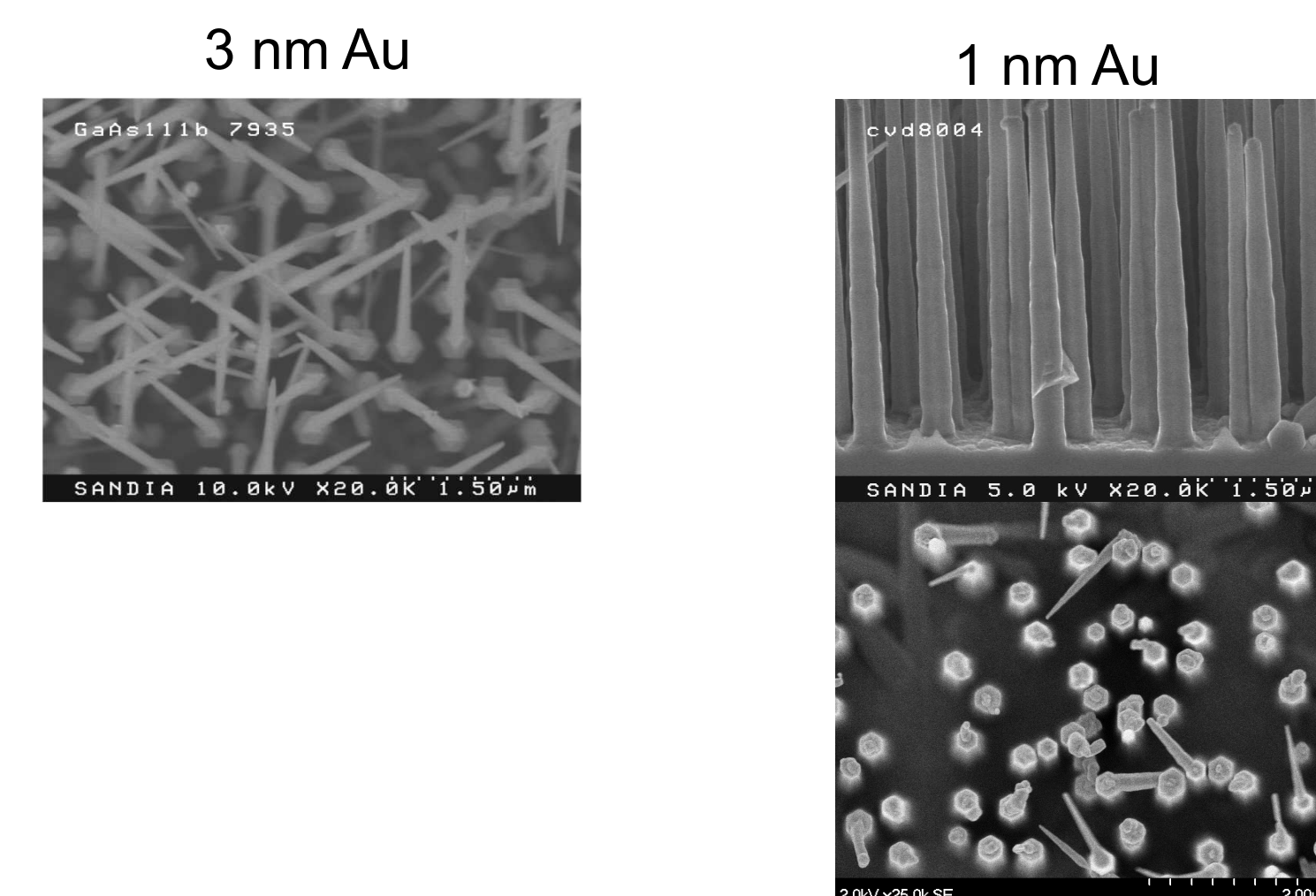


## Nano-Imprint Lithography (NIL) – a route to controlled nanowire size and placement

- NIL allows periodic features to be generated
- Forms mask for Au deposition and liftoff to form localized seeds



## NIL seeded nanowires



## Doping issues with VLS/VSS Nanowires

- Devices require independent control of Fermi level
  - Accomplished through doping
- Temperatures used for VLS/VSS growth is dominated by background impurities
  - Carbon is primary background impurity in MOCVD at low growth temperatures
  - Exacerbated due to incomplete decomposition of metal-organics
- Perform SIMS analysis on planar films due to difficulties doing chemical analysis on nanowires

## Background impurities in III-V films

- Planar GaAs grown at  $450^\circ\text{C}$  is dominated by intrinsic carbon background
  - $1\text{E}19\text{ cm}^{-3}$
- PL doesn't show bandgap reduction expected for heavily p-type GaAs
- Suggests that GaAs nanowires are compensated ( $N_a = N_d$ )
  - Carbon acting like both donor and acceptor
  - SEM images of nanowires show charging effects at high magnifications
- Slightly higher growth temperature ( $500^\circ\text{C}$ ) removes compensation allows planar films to be doped n-type at  $5\text{E}17\text{ cm}^{-3}$  with Si.
- Planar InP grown at  $450^\circ\text{C}$  shows also shows carbon concentration
  - $4\text{E}17\text{ cm}^{-3}$
- TMIn decomposes more efficiently at low temperatures
- Carbon is probably a donor in InP
- Speculate* that InAs will have similar background doping level
  - Carbon is a donor in InAs
- Charging of InAs and InP nanowires not an issue

## Conclusions

- (In,Ga)-(As,P) nanowires can be synthesized by MOCVD using VLS/VSS technique
- Tapering and faceting of GaAs nanowires depends on arsine partial pressure and growth temperature
- Growth on (111)As substrates results in preferential growth of orthogonal nanowires
- NIL seed formation on (111)As substrates is a route to control of nanowire orientation, placement, and size
- Controlled doping of GaAs nanowires is a challenge due to high background carbon levels
- Doping of InP and InAs nanowires appears easier